

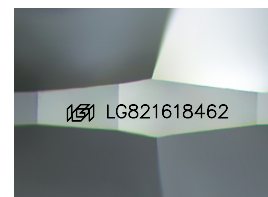
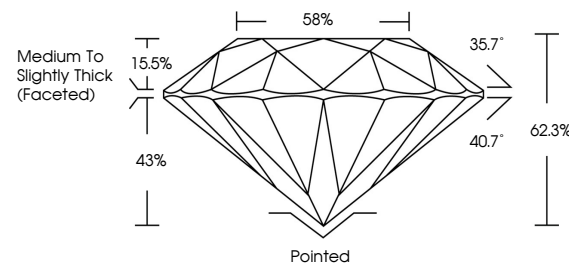


ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

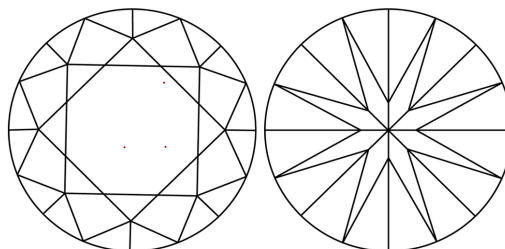
LG821618462
Report verification at igi.org

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



July 27, 2026

IGI Report Number **LG821618462**

Description	LABORATORY GROWN DIAMOND
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Shape and Cutting Style **ROUND BRILLIANT**

Measurements	6.48 - 6.51 X 4.04 MM
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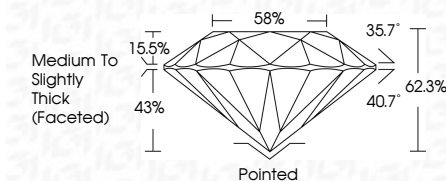
GRADING RESULTS

Carat Weight 1.06 CARAT

Color Grade E

Clarity Grade **VVS 2**

Cut Grade **IDEAL**



ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**Symmetry **EXCELLENT**Fluorescence **NONE**Inscription(s) LG821618462

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa



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July 27, 2026
GI Report No LG821618462
ROUND BRILLIANT

1.06 CARAT	1.06 CARAT
Pointed	Pointed
EXCELLENT	EXCELLENT
EXCELLENT	EXCELLENT
NONE	NONE
4mm (center) 18.46mm	4mm (center) 18.46mm
Medium to Slightly Thick (Faceted)	Medium to Slightly Thick (Faceted)
58%	58%
VS2	VS2
IDPSL	IDPSL
Color Grade	Color Grade
Clarity Grade	Clarity Grade
Cut Grade	Cut Grade
Depth	Depth
Table	Table
Girdle	Girdle
Culet	Culet
Polish	Polish
Symmetry	Symmetry
Fluorescence	Fluorescence
4.8 - 6.51 X 4.04 MM	4.8 - 6.51 X 4.04 MM
Carat Weight	Carat Weight

Comments:
This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.